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APPLICATION NO.	. F	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
09/763,597	763,597 07/02/2001		Charles Love	440431	9284
23548	7590	02/16/2006		EXAMINER	
		MAYER, LTD	MENON, KRISHNAN S		
700 THIRTEENTH ST. NW SUITE 300				ART UNIT	PAPER NUMBER
WASHING	TON, DO	20005-3960	1723		

DATE MAILED: 02/16/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

		77
	Application No.	Applicant(s)
	09/763,597	LOVE ET AL.
Office Action Summary	Examiner	Art Unit
	Krishnan S. Menon	1723
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the	correspondence address
A SHORTENED STATUTORY PERIOD FOR REPL' THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a repl - If NO period for reply is specified above, the maximum statutory period to Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be y within the statutory minimum of thirty (30) o will apply and will expire SIX (6) MONTHS fro o, cause the application to become ABANDO	timely filed lays will be considered timely. m the mailing date of this communication. NED (35 U.S.C. § 133).
Status		
1) Responsive to communication(s) filed on 10 A 2a) This action is FINAL . 2b) This 3) Since this application is in condition for alloward closed in accordance with the practice under B	s action is non-final. nce except for formal matters, p	
Disposition of Claims		
4) ⊠ Claim(s) 1 and 14-31 is/are pending in the approach 4a) Of the above claim(s) is/are withdrays 5) □ Claim(s) is/are allowed. 6) ⊠ Claim(s) 1 and 14-31 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restriction and/or	wn from consideration.	
Application Papers		
9) The specification is objected to by the Examine 10) The drawing(s) filed on is/are: a) acc Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Example 11.	epted or b) objected to by the drawing(s) be held in abeyance. Stion is required if the drawing(s) is constant.	bjected to. See 37 CFR 1.121(d).
Priority under 35 U.S.C. § 119		
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applica rity documents have been recei u (PCT Rule 17.2(a)).	ation No ved in this National Stage
Attachment(s) 1) Notice of References Cited (PTO-892)	4) ☐ Interview Summa	rv (PTO-413)
2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	Paper No(s)/Mail	

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DETAILED ACTION

Claims 1 and 14-31 are pending as amended 8/10/05

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 1. Claims 1,17-21 and 23-31 rejected under 35 U.S.C. 103(a) as being unpatentable over Takahar et al (US 5,147,917) in view of Inoue (US 4,414,028).

Takahar teaches a method of forming a porous medium comprising applying pressure to the medium precursor including inorganic particles and then sinter bonding the particles together to form the porous medium having porosity 50% or more (abstract; examples).

Takahar differs from the claims in the details of the molding process recited. Inoue teaches all those details, such as applying pressure to a first portion and applying pressure separately to a second portion in the molding process (see figures 1, 3 and 6; column 8 lines 16-33), applying pressure in both directions simultaneously, or one after another, medium precursor remaining in the cavity until after the application of pressure, dies moving on a common axis in the opposite direction (dies moving in x-x' direction in figure 6 for example), terminating the axial displacement at the same time, etc. The teaching of the reference is good for many different materials such as metals, ceramic,

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etc., and for making different shapes (see column 2 lines 4-11). It would be obvious to one of ordinary skill in the art at the time of invention to use the teaching of Inoue in the teaching of Takahar because Takahar does not teach the details of molding and sintering, and Inoue teaches the advantages as cited in the column 1 line 37 – column 2 line 16, such as product quality, versatility of the method, etc.

2. Claims 1 and 14-16 are rejected under 35 U.S.C. 103(a) as being unpatentable over

Takahar et al (US 5,147,917) in view of Ohta et al (US 5,198,167).

Claim 1: Takahar teaches a method of forming a porous medium comprising applying pressure to the medium precursor including inorganic particles and then sinter bonding the particles together to form the porous medium having porosity 50% or more (abstract; examples).

Takahar does not teach applying pressure to a first portion and applying pressure separately to a second portion in the molding process. Ohta teaches applying pressure to a first portion and separately applying pressure along a common axis to a second portion in a molding process as claimed in col 13 line 56 – col 14 line 27 and figure 18A-C (64(1) and 64(2) are dies with common axis; first and second portions of the mold can be at opposite ends). It would be obvious to one of ordinary skill in the art at the time of invention to use the teaching of Ohta in the teaching of Takahar for the molding process because Takahar does not teach the specifics of the molding process and suggests optimizing the molding process to suit the needs (see col 3 lines 45-62), and to obtain

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uniformity, proper filling of the mold, avoiding large voids, proper orientation of the particles, etc., as taught by Ohta.

Claims 14-16: first die and second die are taught by Ohta, and they impart predetermined characteristics to respective portions – see the referenced paragraphs. Same compression ratios and same particle density are also obtained: referenced paragraphs; and also optimization as suggested by Takahar in examples.

3. Claims 1, 14-31 are rejected under 35 U.S.C. 103(a) as being unpatentable over

Takahar in view of Munk (US 3,809,736).

Claim 1: Takahar teaches a method of forming a porous medium comprising applying pressure to the medium precursor including inorganic particles and then sinter bonding the particles together to form the porous medium having porosity 50% or more (abstract; examples).

Takahar differs from the claims in the details of the molding process recited. Munk teaches all those details, such as applying pressure to a first portion and applying pressure separately to a second portion in the molding process in common axis in opposite direction (direction x, figure 1) or same direction (figure 2: dies 4 and 6), applying pressure in both directions simultaneously, or one after another, medium precursor remaining in the cavity until after the application of pressure, dies moving on a common axis in the opposite direction (see figures: the two dies in the x-direction in figure 1 are independent of each-other), terminating the axial displacement at the same time, etc. It would be obvious to one of ordinary skill in the art at the time of invention to

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use the teaching of Munk in the teaching of Takahar because Takahar does not teach the details of molding and sintering, and Munk teaches the process for the specific shape, and also the advantages as cited in column 2 lines 60-70, such as consistency and compression ratio.

Response to Arguments

Applicant's arguments filed 8/10/05 have been fully considered but they are not persuasive.

In response to the argument that Ohta uses the primary and secondary pressing forces only to orient the fibers is not correct. Ohta also teaches that the secondary forces from the dies 64(1) and 64(2) can be used as back-pressure to load the material in the die. See column 14 lines 61-67. The back-pressure also would help avoid large voids – see column 14 lines 55-60. In addition, it may be noted that Ohta provides an apparatus for the molding process. The use of the apparatus is not limited by the specific material Ohta processes. The test for obviousness is not whether the features of a secondary reference may be bodily incorporated into the structure of the primary reference; nor is it that the claimed invention must be expressly suggested in any one or all of the references. Rather, the test is what the combined teachings of the references would have suggested to those of ordinary skill in the art. See *In re Keller*, 642 F.2d 413, 208 USPQ 871 (CCPA 1981). One of ordinary skill in the art could also use the teaching of adding whiskers by Ohta in the teaching of Takahar for reinforcement of the sintered metal filter.

Conclusion

Applicant's amendment necessitated the new ground(s) of rejection presented in this Office action. Accordingly, **THIS ACTION IS MADE FINAL**. See MPEP § 706.07(a). Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the date of this final action.

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Krishnan S. Menon whose telephone number is 571-272-1143. The examiner can normally be reached on 8:00-4:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Wanda L. Walker can be reached on 571-272-1151. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Krishnan Menon Patent Examiner 2/11/06 JOHN KIM Prmary PATENT EXAMINER